

Attorney Docket No. 49481 (70551)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT:

M. HATANAKA et al.

EXAMINER:

P. Natividad

U.S.S.N.:

09/471,829

ART UNIT:

2877

FILED:

December 23, 1999

TITLE:

THICKNESS MEASUREMENT APPARATUS OF THIN FILM USING

LIGHT INTERFERENCE METHOD

CERTIFICATE OF MAILING

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Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Sir:

In response to the office action dated April 24, 2003, please consider the following amendments and remarks in favor of the allowance of claims 1 and 3-20 of the above-referenced patent application. A version of the amendments that includes

In the Claims

Please cancel claims 2 and 21-59 without prejudice.

markings to denote the amended subject matter is included below.

Please amend claims 1 and 19 as follows: